

10/653213

Sheet 1 of 1

FORM PTO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. 025720-00011	SERIAL NO. New Appln.
LIST OF REFERENCES CITED BY APPLICANT  (Use several sheets if necessary)		APPLICANT Masahiko IMAI et al	
		FILING DATE September 3, 2003	GROUP

## U.S. PATENT DOCUMENTS

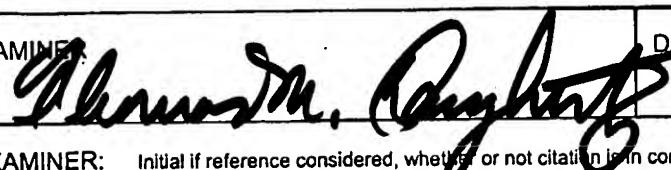
EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						

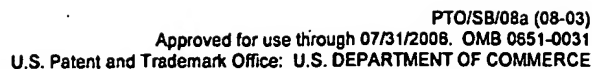
## FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION YES NO PART.		
TMD	AG	2001-53579	2/23/01	Japan					XX
TMD	AH	2516817	7/25/96	Japan				XX	
TMD	AI	3-101280	4/26/91	Japan					XX
TMD	AJ	11-55070	2/26/99	Japan				XX	
	AK								
	AL								

## OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

TMD	AM	"Theoretical Analysis of SAW Propagation Characteristics Under the Strained Medium and Applications for High Temperature Stable High Coupling SAW Substrates", YAMANOUCI et al, 1999 IEEE Ultrasonics Symposium, pgs. 239 - 242.
TMD	AN	"Temperature Stable SAW Devices Using Directly Bonded LiTaO3/Glass Substrates", SATO et al, 1998 IEEE Ultrasonics Symposium, pgs. 335 - 338.
TMD	AO	"SAW Properties of SiO2/128° Y-X LiNbO3 Structure Fabricated by Magnetron Sputtering Technique", YAMANOUCI et al, IEEE Transactions on Sonics and Ultrasonics, Vol. SU-31, No. 1, January 1984, pgs. 51 - 57.

EXAMINER: 	DATE CONSIDERED 7-15-05
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	



**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**  
**Form PTO/SB/08a**

Application Number	10/653,213
Filing Date	September 3, 2003
First Named Inventor	M. Imai et al.
Art Unit	2834
Examiner Name	T. Dougherty
Attorney Docket Number	025720-00011

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[illegible][illegible]

Examiner Signature	<i>Thomas M. Edwards</i>	Date Considered	9-15-05
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 809. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. <sup>1</sup>Unique citation designation number. <sup>2</sup>See attached Kinds of U.S. Patent Documents. <sup>3</sup>Enter Office that issued the document, by the two-letter code. <sup>4</sup>For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup>Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup>Applicant is to place a check mark here if English language translation is attached. AB indicates that only an English language abstract is attached.